

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q68895

Shinji YAMAMORI, et al.

Appln. No.: 10/092,591

Group Art Unit: 1743

Confirmation No.: 1085

Examiner: Monique T. COLE

Filed: March 8, 2002

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SENSOR FOR MEASURING CARBON DIOXIDE IN RESPIRATORY GAS

<u>INFORMATION DISCLOSURE STATEMENT</u> <u>UNDER 37 C.F.R. §§ 1.97 and 1.98</u>

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith, except for the following: U.S. patents and/or U.S. patent publications; and co-pending non-provisional U.S. applications filed after June 30, 2003.

The present Information Disclosure Statement is being filed after the later of three months from the application's filing date and the mailing date of the first Office Action on the merits, but before a Final Office Action, Notice of Allowance, or an action that otherwise closes

prosecution in the application (whichever is earlier), and therefore Applicant is filing concurrently herewith a Statement Under 37 C.F.R. § 1.97(e). No fee under 37 C.F.R. § 1.17(p) is required.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for foreign language documents, Applicant encloses herewith a copy of a Communication from a foreign patent office in a counterpart application citing such documents, together with an English-language version (if not already included) of at least that portion of the Communication indicating the degree of relevance found by the foreign patent office.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for foreign language documents, Applicant submits the following explanations:

The Japanese Examiner asserts that JP 1-13439 discloses a sensor for measuring a concentration of carbon dioxide in respiratory gas, comprising: a semiconductor substrate on which a semiconductor laser 1 and a semiconductor photo detector 3 are arranged while defining an optical path groove 2 therebetween; and an elastic support member 42 provided with a gap 43 (cf., page 2, lower left column, lines 10-13; page 2, lower right column, line 9 through page 3, upper left column, line 14; page 4, upper left column, line 5 through upper right column, line 13; Figs. 1, 8 and 9).

The Japanese Examiner asserts that JP 2000-312670 and JP 63-11133 teaches that a sensor is attached to an area located below nostrils (cf., [0020]-[0025] of JP '670 and page 4, lower left column, lines 10-15 of JP '133).

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/092,591

The submission of the listed documents is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account.

Respectfully submitted,

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: April 11, 2006

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SENSOR FOR MEASURING CARBON DIOXIDE IN RESPIRATORY GAS For:

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

lannon

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WASHINGTON OFFICE 23373 **CUSTOMER NUMBER**

Date: April 11, 2006

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Substitute for Form 1449 A & B/PTO	Complete if Known			
Substitute for Torin 1445 At a Dil 10	Application Number	10/092,591		
OIPE INFORMATION DISCLOSURE	Confirmation Number	1085		
STATEMENT BY APPLICANT	Filing Date	March 8, 2002		
20:\	First Named Inventor	Shinji YAMAMORI		
PR 1 1 2006 (use as many sheets as necessary)	Art Unit	1743		
	Examiner Name	Monique T. COLE		
Sheet 1 of 1	Attorney Docket Number	O68895		

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number		Publication Data		
		Number	Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
_		US				
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FOREIGN PATENT DOCUMENTS							
Examiner Cite Initials* No.1	Foreign Patent Document			Publication Date	Name of Patentee or		
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
		JР	64-13439A		01/18/1989		
		JP	63-11133		01/18/1988		
		JР	2000-312670	A	11/14/2000		

NON PATENT LITERATURE DOCUMENTS				
		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation	
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Examiner Signature	Date Considered	1
- Sharmer Digitater C	Date Considered	<u> </u>

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.